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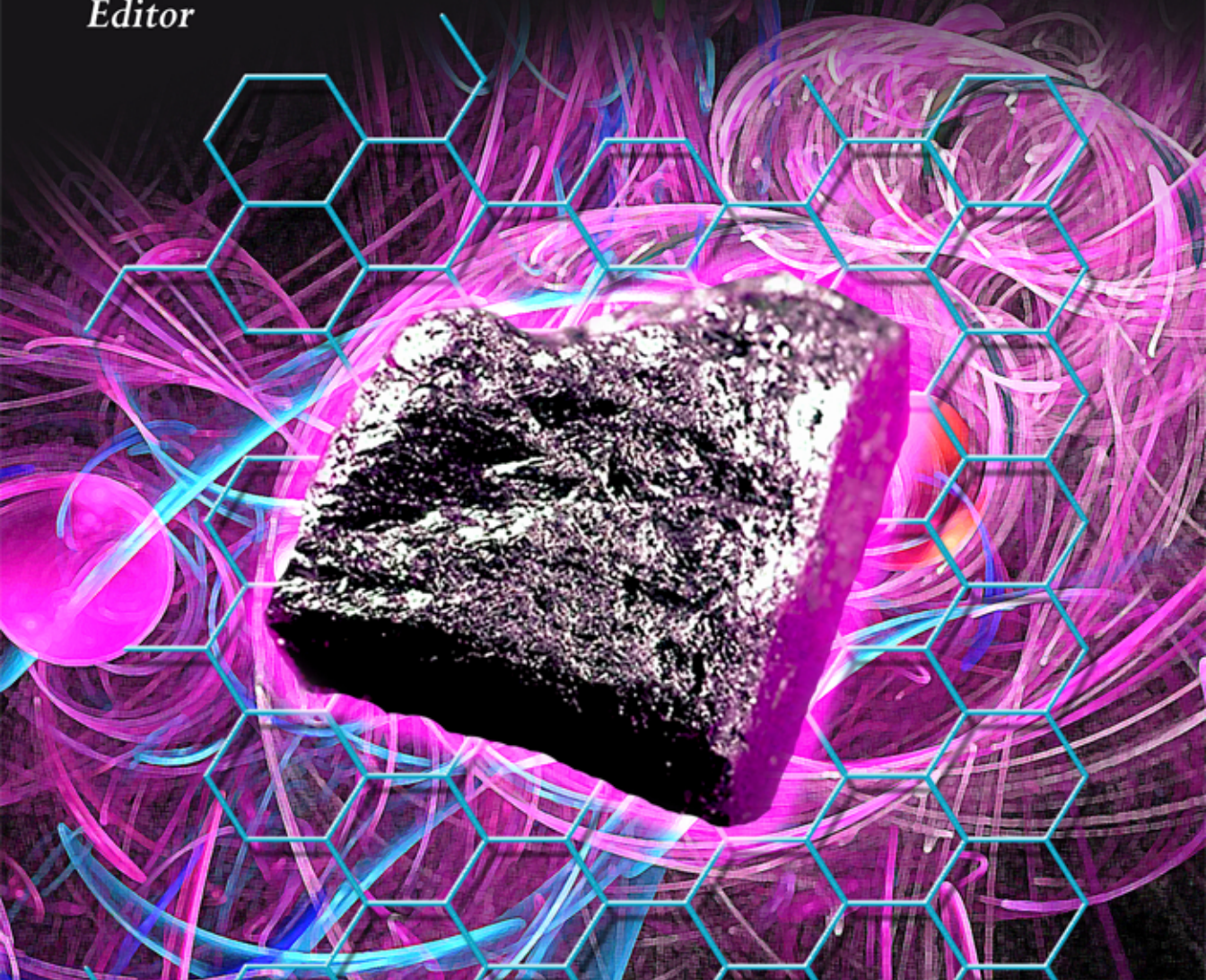
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GRAPHITE

Properties, Occurrences and Uses

Quinton C. Campbell

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CONTENTS

Preface		vii
Chapter 1	Advances in Gasification of Nuclear Graphite: Chemical Reactions, Kinetics Model Validation and Analyses Results <i>Mohamed S. El-Genk and Jean-Michel Tournier</i>	1
Chapter 2	Structural Mimicry of Carbon Driven by Ultrashort Laser Pulses <i>Sergey I. Kudryashov and Nikolay N. Melnik</i>	69
Chapter 3	Nanoscale $sp^2 \rightarrow sp^3$ Conversion by Visible Light Irradiation in Graphite <i>L. Radosinski, K. Nishioka, K. Nasu and D. Wojt</i>	125
Chapter 4	Graphite Powder and Related Material as the Principal Components of Carbon Paste Electrodes <i>Ivan Švancara, Tomáš Mikysek, Matěj Stočes and Jiří Ludvík</i>	163
Chapter 5	Graphite: Sailing in a Cost-Effective Electron Sea <i>Gabriela da Cruz Mello, Edilson Moura Pinto, Eduardo Ariel Ponzio and Felipe Silva Semaan</i>	189
Chapter 6	Microstructural Factors Which Govern the Oxidative Properties of Graphite <i>Heinrich Badenhorst, Brian Rand and Walter W. Focke</i>	215
Chapter 7	Application of Graphite Nanoparticles in Ultrafast Fiber Lasers <i>Yung-Hsiang Lin and Gong-Ru Lin</i>	255
Chapter 8	Cluster Deposition and Implantation on/in Graphite <i>Vladimir N. Popok</i>	279
Chapter 9	Thermal Stability of Fully Lithiated Graphite <i>Yoon-Soo Park and Sung-Man Lee</i>	299
Chapter 10	Ethylene-Octene Copolymer/Graphite Composites: Electrical and Thermal Conductivities and Flame Resistance <i>Petr Svoboda</i>	319
Index		339

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Chapter 8

CLUSTER DEPOSITION AND IMPLANTATION ON/IN GRAPHITE

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ABSTRACT

Cluster ion beam technique is a versatile tool which can be used for controllable formation of nanosize objects on a surface as well as modification and processing of surfaces and shallow layers on an atomic scale. In this chapter an overview of research on cluster interaction with graphite is presented. One of the emphases is put on pinning of metal clusters on graphite with a possibility of following selective etching of graphene layers. The other main topic of concern is related to the phenomenon of cluster stopping and the development of scaling law for cluster implantation in graphite. Graphite is chosen for experiments because it is a good model material; it has an atomically smooth surface that makes it easy to resolve very small deposited clusters or damaged areas. Layered structure of graphite with strong covalent bonds in the graphene sheets and very weak van der Waals interactions between them is an interesting type of crystalline arrangement for modelling of clusters implantation. Additionally, there is rapidly increasing research activities on graphene which promises a number of applications in nanoelectronics, plasmonics, sensing etc. Therefore, understanding of particle behaviour on soft landing or pinning on graphene is of considerable practical importance.

INTRODUCTION

Ion-beam treatment of materials is one of very widely applied techniques for numerous research and industrial purposes. Along with traditional monomer ions, atomic or molecular clusters (aggregates of atoms or molecules) have attracted considerable attention during the last two decades [1-6]. A cluster can be formed from atoms of the same chemical element or

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